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		Application Number			10/650,88	36 C	ENTRAL	PAX	CENTE	
		Filing Date			August 2	8, 2003	FEB	<u> ۲</u> -	2008	
		First Named Inventor			Chen, et al.					
		Attorney Docket Number			TSM 6283131 RI					
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Typed or Printed Name	Steven H. Slater						- · · · · · · · · · · · · · · · · · · ·			
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### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patentees:

Chen, et al.

Docket No.:

TSM 6283131 RI

Serial No.:

10/650,886

Patent No.:

RE 40,007 E

Date Filed:

August 28, 2003

Issue Date:

January 22, 2008

Title:

In-Situ Strip Process for Polysilicon Etching in Deep Sub-Micron Technology

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- Change of Correspondence Address - Patent (1 page)

Respectfully submitted,

(Júlia Davis

Legal Assistant

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